

jc812 U.S. PRO
01/15/02

01-22-02 A

Docket No. 5206.P1/TCG/LPCVD/LE

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10/051651
01/15/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Box Patent Application
 Commissioner for Patents
 Washington, D.C. 20231

Re: Inventor(s): Xiaoliang Jin, Shulin Wang, Lee Luo, Henry Ho, and Steven A. Chen
 Title: Emissivity-Change-Free Pumping Plate Kit in a Single Wafer Chamber

Transmitted herewith is the patent application identified above, including:

- Specification, claims and abstract, totaling 21 pages.
- Drawings totaling 15 pages, Formal Informal.
- Executed Declaration and Power of Attorney.
- Assignment of the invention to Applied Materials, Inc.
- Assignment Recordation Cover Sheet

FEE CALCULATION					
Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	25	- 20 =	5	X \$18.00	90.00
Independent Claims	4	- 3 =	1	X \$84.00	84.00
Basic Filing Fee				\$740.00	\$740.00
TOTAL FEES					\$914.00

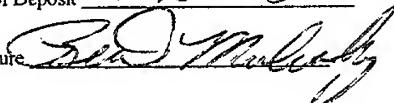
- The Commissioner is hereby authorized to charge \$914.00 to Deposit Account No. 50-1074.
- The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 50-1074. A duplicate copy of this transmittal is enclosed.
- Please address all future correspondence to:

PATENT COUNSEL
 APPLIED MATERIALS, INC.
 Legal Affairs Department
 P.O.BOX 450A
 Santa Clara, CA. 95052

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to: Box Patent Application Assistant Commissioner for Patents, Washington, D.C. 20231

Express Mail Receipt No EL37U832542U5

Date of Deposit 1-15-02

Signature 

Respectfully submitted,

Robert W. Mulcahy
 Registration No. 25,436